AP20 Res'dFG...770 25 JUN 2006

S/N

Unknown

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

KITAOKA, et al.

Examiner:

Unknown

Serial No.:

Unknown

Group Art Unit:

Unknown

Filed:

Herewith

Docket:

10873.1915USWO

Title:

METHOD FOR PRODUCING GROUP III NITRIDE

CRYSTAL, GROUP III NITRIDE CRYSTAL OBTAINED BY SUCH METHOD, AND GROUP III NITRIDE SUBSTRATE

USING THE SAME

CERTIFICATE UNDER 37 CFR 1.10

Express Mail mailing label number: EV 858801894 US

Date of Deposit: June 26, 2006

I hereby certify that the papers listed below are being deposited with the United States Postal Service Express Mail Post Office to Addressee service under 37 CFR 1.10 in an envelope addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Name: Abbie Larkin

INFORMATION DISCLOSURE STATEMENT (37 C.F.R. § 1.97(c))

Mail Stop PCT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

With regard to the above-identified application, the items of information listed on the enclosed Form 1449 are brought to the attention of the Examiner.

This statement should be considered because it is submitted within three months of the filing date of the above-identified application, which is not an application under 37 C.F.R. §1.53(d). Accordingly, no fee is due for consideration of the items listed on the enclosed Form 1449.

In accordance with 37 C.F.R. §1.98(a)(2), a copy of each foreign document or other information listed on the enclosed Form 1449 is provided. As this application was filed after June 30, 2003, copies of the cited U.S. Patent Documents are not included.

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A concise explanation of the relevance of each non-English language document or other information is a follows (37 C.F.R. §(a)(3)):

An English abstract and/or a partial English translation has been included for each Japanese reference.

No representation is made that a reference is "prior art" within the meaning of 35 U.S.C. §§ 102 and 103 and Applicants reserve the right, pursuant to 37 C.F.R. § 1.131 or otherwise, to establish that the reference(s) are not "prior art." Moreover, Applicants do not represent that a reference has been thoroughly reviewed or that any relevance of any portion of a reference is intended.

Consideration of the items listed is respectfully requested. Pursuant to the provisions of M.P.E.P. 609, it is requested that the Examiner return a copy of the attached Form 1449, marked as being considered and initialed by the Examiner, to the undersigned with the next official communication.

Please charge any additional fees or credit any overpayment to Deposit Account No. 50-3478.

Respectfully submitted,

HAMRE, SCHUMANN, MUELLER & LARSOŃ, P.C. P.O. Box 2902-0902 Minneapolis, MN 55402-0902 (612) 455-3800

figlas P. Mueller

Reg. No. 30,300

Dated: June 26, 2006

DPM/pjk

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PATENT TRADEMARK OFFICE

Date Mailed: June 26, 2006

IAP20 Rec'd PC1/770 26 JUN 2006

FORM 1449*

INFORMATION DISCLOSURE STATEMENT

Docket Number: 10873.1915USWO

Application Number:

104584725

IN AN APPLICATION

Applicant: KITAOKA, et al.

(Use several sheets if necessary)

Filing Date: Herewith Group Art Unit: Unknown

		U.S. I	PATENT DOCUMENT	ΓS			
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	6,592,663	July, 2003	Sarayama, et al.				
	2006/0051942	March, 2006	Sasaki, et al.				
							· · · ·
	1	FOREIG	N PATENT DOCUMI	ENTS		<u> </u>	
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	56-160400	December, 1981	Japan			Abstract	
	95/04845	February, 1995	WIPO				
	11-135831	May, 1999	Japan			Partial & Abstract	
	2002-293696	October, 2002	Japan			Abstract	
	2003-257998	September, 2003	Japan		:	Abstract	,
	ОТНЕ	R DOCUMENTS (In	cluding Author, Title, D	ate, Pertinent P	ages, Etc.)		
		a, et al., Synthesis of pp. L1440-1442	Bulk GaN Single Crysta	lls Using Na-Ca	Flux" Jpn. J. App	l. Phys. vol. 41	, Decemb
						·	**

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EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.